

INFORMATION DISCLOSURE
CITATION

Docket No.: 0437-A-269
Serial No.: 10/034,788
Applicant: Farrell et al.
Filing Date: 12/27/01

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class/ Subclass
RECEIVED MAR 11 2002				
GROUP 3600				

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class/ Subclass

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

lz "Horizontal Wafer Transfer Machines", Handling tools and equipment for the semiconductor industry since 1975!, H-Square Corporation, Sunnyvale, California, pp. 8-1 - 8-5.

lz "E.T. 1000 Wafer Transfer System", "E.T. 2000 Wafer Transfer System", and "Ergonomic Wafer Transfer System", MGI Electronics, Tempe, Arizona.

Examiner

Cam 9/24

Date Considered

9-26-03